

Docket No.: 49677-107

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Toshihiro OOISHI, et al.

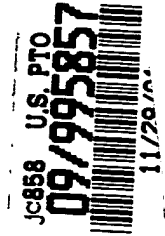
Serial No.:

Filed: November 29, 2001

For: METHOD OF PRODUCING GLASS PARTICLES DEPOSIT

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: Group Art Unit:

: Examiner:
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CLAIM OF PRIORITY

Commissioner for Patents
Washington, DC 20231

Sir:

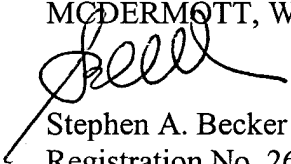
In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

Japanese Patent Application No. 2000-362829, filed November 29, 2000

A certified copy will be filed in due course.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


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